



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2851

00862.022151.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Masaya OGURA et al. ) Examiner: H. Nguyen  
Application No.: 09/811,419 ) Group Art Unit: 2851  
Filed: March 20, 2001 )  
For: EXPOSURE APPARATUS, METHOD OF ) May 19, 2003  
MANUFACTURING SEMICONDUCTOR: ) (Monday)  
DEVICES AND PLANT THEREFOR )

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

TECHNOLOGY CENTER 2800

MAY 21 2003

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#11/B  
5/23/03  
Jenn  
(NE)

AMENDMENT AFTER FINAL REJECTION  
WITH PETITION FOR EXTENSION OF TIME

05/20/2003 MDAHTE1 00000103 09811419

01 FC:1252

410.00 DP

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 17, 2002, for two months from March 17, 2003, up to and including Monday, May 19, 2003. A check in the amount of \$410.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit

any overpayment, to Deposit Account 06-1205.

Void date: 05/20/2003 MDAHTE1  
05/20/2003 MDAHTE1 00000101 09445093  
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Please amend the above-identified application as follows in response to the Official Action dated December 17, 2002:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."